

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention

METHOD AND SYSTEM FOR DYNAMIC MODELING AND
RECIPE OPTIMIZATION OF SEMICONDUCTOR ETCH
PROCESSES

Application Number : 10/523777
Confirmation Number: 5732
First Named Applicant: Kun Li
Attorney Docket Number: VOY007US
Art Unit: 2825
Examiner:
Search string: (6133132).pn



US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6133132	2000-10-17	Toprac et al.			

Signature

Examiner Name	Date